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Substitute for form 1449A/PTO	Application Number	10/759,081	RECEIVED
INFORMATION DISCLOSURE	Filing Date	January 20, 2004	CENTRAL FAX CENTE
STATEMENT BY APPLICANT	First Named Inventor	Dr. Chou H. Li	NOV 0 1 2006
	Group Art Unit	2815	
	Examiner Name	William F. Kraig	
Sheet 1 of 5	Attorney Docket Number	2480.202	

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	АВ	3,585,714	Li	06-22-1971
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	AE	3,233,305	Dill	02-08-1966
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	AG	3,360,696	Neilson, et al.	12-26-1967
·	АН	3,411,051	Kilby	11-12-1968
	Al	3,426,253	LaRocque, et al.	02-04-1969
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	AK	3,970,486	Kool	07-20-1976
	AL	3,345,222	Nomura, et al.	10-03-1967
	AM	3,440,717	Hill	04-29-1969
<del></del>	AN	3,492,174	Nakamura, et el.	01-27-1970
· · · · · · · ·	AO	3,520,139	Elkind, et al.	07-14-1970
	AP	3,515,956	Martin, et al.	06-02-1970

<sup>\*</sup>EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Iriclude copy of this form with noxt communication to applicant.

<sup>&</sup>lt;sup>1</sup>Unique citation designation number. <sup>2</sup>See attached Kinds of U.S. Patent Documents. <sup>3</sup>Enter Office that issued the document, by the two-letter code. <sup>4</sup>For Japanese patent documents, the indication of the year of the reign of the Emperor must precede the serial number of the patent document. <sup>5</sup>Kind of document by the appropriate symbols as indicated on the document under WIPO Standard ST, 16 if possible. <sup>6</sup>Applicant is to place a check mark here if English language translation is attached. AB Indicetes that only an English language abstract is attached.

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Sheet 2 of 5	Attorney Docket Number	2480.202	

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	AS	3,209,428		Barbaro	10-05-1965
	АТ	4,139,442		Bondur, et al.	02-13-1979
	ΑŲ	5,254,218		Roberts, et al.	10-19-1993
	AV	3,321,340	-	Murphy	05-23-1967
	AW	3,430,109		LI	02-25-1969
	AX	3,622,382		Brack, et al.	11-23-1971
	AY	4,916,513		U	04-10-1990
	AZ	5,040,034		Murakami, et al.	08-13-1991
	ВА	5,082,793		Li	01-21-1992
	ВВ	3,376,172		Byczkowski	04-02-1968
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	Examiner Name	William F. Kraig	
Sheet 3 of 5	Attorney Docket Number	2480.202	

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	BJ	3,136,897		Kaufman	06-09-1964
·	ВК	5,361,326		Aparicio, IV, et al.	11-01-1994

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· -		Foreign Patent Document					
Examiner Initials*	Cite No.1	Office <sup>3</sup>	Number <sup>4</sup>	Kind⁵ Code (if known)	Name of Patentee or Applicant of Cited Document	Date of Publication of Cited Document MM-DD-YYYY	T
	BL	GB	1086607			10-1967	H
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<sup>&</sup>lt;sup>1</sup>Unique citation designation number. <sup>2</sup>See attached Kinds of U.S. Patent Documents. <sup>3</sup>Enter Office that issued the document, by the two-letter code. <sup>4</sup>For Japanese patent documents, the indication of the year of the reign of the Emperor must precede the serial number of the patent document. <sup>6</sup>Kind of document by the appropriate symbols as indicated on the document under WIPO Standard ST. 16 if possible. <sup>6</sup>Applicant is to place a check mark here if English language translation is attached. AB indicates that only an English language abstract is attached.

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STATEMENT BY APPLICANT	First Named Inventor	Dr. Chou H. Li	OUNTRAL FAX DENTER
	Group Art Unit	2815	NOV 0 1 2006
	Examiner Name	William F. Kraig	
Sheet 4 of 5	Attorney Docket Number	2480.202	

		NON PATENT LITERATURE DOCUMENTS	
Examiner initials*	Cite No.1	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the ltem (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published	T <sup>2</sup>
	ВО	"Integrated Circuits Design Principles and Fabrication," McGraw-Hill Book Co., Inc., 1965, pp. 127-31; 145-50; 174-85; Fig. 5-4(a), p. 131; Fig. 5-23, p. 146; Fig. 5-25 -5-27, pp. 147-48; Fig. 7-1, p. 175; Fig. 7-2, p. 176; Fig. 7-6(a), p. 179.	
	BP	"New Isolation Method Shrinks Bipolar Ics," Electronics, McGraw-Hill, Mar. 1, 1971, pp. 52-55, Fig. 5-6, p. 55.	
	BQ	"Diffusion Depths in Silicon Measured Using Cylindrical Grooves," The American Physical Society Abstracts from the Epitome of the 1956 Monterey Meeting, Session H, Nov. 1956.	
	8R	McDonald, et al., "Measurement of the Depth of Diffused Layers in Silicon By the Grooving Method," Journal of the Electrochemical Society, Vol. 109, No. 2, Feb. 1962, pp. 141-144 – see Fig. 2 and p. 143.	
	BS	Jones, R.E. and Doo, Y., "A Composite Insulator-Junction Isolation," Electrochemical Technology, May-June 1967.	
	ВТ	Breener, S.S., "The Growth of Whiskers by the Reduction of Metal Salts," Acta Metallurgica, Vol. 4, Jan. 1956, pp. 62-74.	
	BŲ	Stiles, P.J., et al., "Schottky Barrier Diode", IBM Technical Disclosure Bulletin, Vol. 11 No. 1, June 1968, p. 20.	
	BV	Doo, Y., et al., "Making Monolithic Semiconductor Structures for Integrated Circuits Using Composite Insulation and Junction Isolation Techniques," IBMS Technical Disclosure Bulletin, Vol. 8 No. 4, Sept. 1965, pp. 659-660.	
	BW	Phillips, A.B., "Transistor Engineering," McGraw-Hill, 1962, pp. 111-115.	
	ВХ	Burrill, J.T., et al., "Ion Implantation as a Production Technique," IEEE Transactions on Electron Devices, Vol. Ed-14, No. 1, Jan. 1967, pp. 10-17.	-
	BY	Buchanan, B., et al., "High Energy (1 to 2.5 Mev) Ion Implantation For Obtaining Novel Semi-Conductor Junction Structures," Air Force Cambridge Res. Labs., Off. Of Aerospace Research, Bedford, MA, pp. 649-684.	
	BZ	Gibbons, J.F., "Ion Implantation in Semiconductors-Part I Range Distribution Theory and Experiments," Proceedings of the IEEE, Vol. 56, No.3, March 1968, pp. 295-318.	

<sup>\*</sup>EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

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	Examiner Name	William F. Kraig	
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		NON PATENT LITERATURE DOCUMENTS	
Examiner Initials*	Cite No.1	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the ltem (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published	T²
	CA	NOTES, Solid-State Electronics, Pergamon Press. 1967, Vol. 10, pp. 1105-1108, Printed in Great Britain.	
	СВ	Kennedy, D.P., et al., "Calculations of Impurity Atom Diffusion Through a Narrow Diffusion Mask Opening," IBM Journal, Jan. 1966, pp. 6-12.	
	СС	Appels, J.A., et al., "Local Oxidation of Silicon and Its Application in Semiconductor-Device Technology, Philips Res. Repts. 25, 1970, pp. 118-132.	
	CD	Doo, V.Y., "Silicon Nitride, A New Diffusion Mask, IEEE Transactions on Electron Devices, Vol. Ed13, No. 7, July 1966, pp. 561-563.	
	CE	S.S. Brenner, "The Growth of Whiskers by the Reduction of Metal Salts", Acta Mettalurgica, Vol. 4 (January 1956) pp. 62-74.	

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<sup>&</sup>lt;sup>1</sup>Unique citation designation number. <sup>9</sup>See attached Kinds of U.S. Patent Documents. <sup>9</sup>Enter Office that issued the document, by the two-letter code. <sup>4</sup>For Japanese patent documents, the indication of the year of the reign of the Emperor must precede the serial number of the patent document. <sup>5</sup>Kind of document by the appropriate symbols as indicated on the document under WIPO Standard ST. 16 if possible. <sup>6</sup>Applicant is to place a check mark here if English language translation is attached. AB indicates that only an English language abstract is attached.

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### CERTIFICATE OF FACSIMILE

I hereby certify that this paper is being facsimile transmitted to Examiner William F. Kraig, Art Unit 2815, at the U.S. Patent and Trademark Office, Fax No. (571) 273-8300 on November 1, 2006.

Keith R. Lange Reg. 44,201

#### PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:	)
Dr. Chou H. Li	) Examiner: William F. Kraig
Appl. No.: 10/759,081	) Art Unit: 2815
Filed: January 20, 2004	) Atty. Dkt. No.: 2480.202
For: INTEGRATED CIRCUIT DEVICE	) )
MAIL STOP AMENDMENT Commissioner for Patents	

### INFORMATION DISCLOSURE STATEMENT

Sir:

P.O. Box 1450

Alexandria, Virginia 22313-1450

In fulfillment of the requirements of candor and good faith set forth in 37 C.F.R. §1.56, Applicant submits herewith the following Information Disclosure Statement in accordance with the provisions of 37 C.F.R. §§1.97 and 1.98 for the above-referenced patent application.

As this Information Disclosure Statement is being filed within three months of the filing date of a Request for Continued Examination, it is deemed to be timely filed, and accordingly no fee is believed to be due. However, if

Applicant is incorrect in this regard, you are hereby authorized to charge any such fee, or credit any overpayments, to Deposit Account No. 50-0644, and are respectfully requested to notify the undersigned of any such charge or credit.

# U.S. PATENT DOCUMENTS

U.S. PATENT/	PATENTEE/ ISSUE	E/PUBLICATION
APPL. PUBL. NO.	APPLICANT DATE	(MM-DD-YYYY)
3,283,171	Seeds	11-01-1966
3,585,714	Li	06-22-1971
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3,098,160	Noyce	07-16-1963
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Jones, R.E. and Doo, Y., "A Composite Insulator-Junction Isolation," <u>Electrochemical Technology</u>, May-June 1967.

Breener, S.S., "The Crowth of Whiskers by the Reduction of Metal Salts," <u>Acta Metallurgica</u>, Vol. 4, Jan. 1956, pp. 62-74.

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Buchanan, B., et al., "High Energy (1 to 2.5 Mev) Ion Implantation For Obtaining Novel Semi-Conductor Junction Structures," <u>Air Force Cambridge Res. Labs., Off. Of</u> Aerospace Research, Bedford, MA, pp. 649-684.

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<u>Transactions on Electron Devices</u>, Vol. Ed.-13, No. 7, July
1966, pp. 561-563.

S.S. Brenner, "The Growth of Whiskers by the Reduction of Metal Salts", Acta Mettalurgica, Vol. 4 (January 1956) pp. 62-74.

As provided by 37 C.F.R. §1.98(d)(1), Applicant has not provided copies of any of the above-references, as it is believed that each was submitted in parent application 08/483,938, now U.S. Patent No. 7,038,290, to which the present application claims priority, but will do so upon request of the Office.

Each of the above-cited references are listed on Applicant's enclosed Substitute Form PTO-1449. The Examiner is respectfully requested to acknowledge consideration of each reference listed thereon by initialing in the designated area and returning a copy of same to Applicant.

Please direct any questions concerning this matter to Applicant's undersigned representative, who can be reached directly at (610) 869-6302.

Respectfully submitted, HALL, VANDE SANDE & PEQUIGNOT, LLP ATTORNEYS FOR APPLICANT

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Dated: November 1, 2006